

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: Confirmation No.: 5377

Makiko KITAZOE, et al Art Unit: 1712

Application No.: 10/591,905 Examiner: Keath T. CHEN

Filed: November 6, 2006 Attorney Docket No.: 029567-00010

For: SELF-CLEANING CATALYTIC CHEMICAL VAPOR DEPOSITION APPARATUS  
AND CLEANING METHOD THEREOF

**RESPONSE UNDER 37 C.F.R. §1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 31, 2011

Sir:

This paper is submitted in reply to the June 3, 2011 Office Action.

Amendments to the claims being on page 2; and

Remarks begin on page 7.